



## RHODE ISLAND

### DEPARTMENT OF ENVIRONMENTAL MANAGEMENT

OFFICE OF WATER RESOURCES

235 Promenade Street, Providence, Rhode Island 02908

May 14, 2020

#### CERTIFIED MAIL

Mr. Scott Samuelson  
Fuji Clean USA, LLC  
41-2 Greenwood Road, Ste 2  
Brunswick, ME 04011 USA

**RE: Monitoring Protocol for Nitrogen Removal Systems Final Report Approval - Fuji Clean  
Alternative/Experimental OWTS Technology Certification (CEN5, CEN7, and CEN10)**

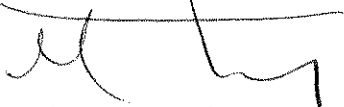
Dear Mr. Samuelson:

The RI Department of Environmental Management (RIDEM) Onsite Wastewater Treatment Systems (OWTSs) Program received the *April 27, 2020 Effluent Quality Monitoring Results Final Report for the Fuji Clean CEN Series Models* and associated attachments on April 30, 2020. The Final Report was submitted to the RIDEM to demonstrate compliance with the RIDEM Monitoring Protocol for Nitrogen Removal Systems dated November 27, 2019. Compliance with this monitoring protocol was a condition of Fuji Clean USA, LLC's RIDEM A/E Technology Approval of Fuji Clean Models CEN5, CEN7, and CEN10 that was issued on November 27, 2019.

The DEM has completed the review of the *April 27, 2020 Effluent Quality Monitoring Results Final Report for the Fuji Clean CEN Series Models* and has determined that the conditions of the RIDEM Monitoring Protocol for Nitrogen Removal Systems dated November 27, 2019 have been satisfied. Going forward there are no longer any limits in effect regarding the total number of Fuji Clean systems that may be installed in RI as long as those systems are designed and installed in compliance with an approved OWTS Construction Permit, the RIDEM OWTS Rules, and as long as the RIDEM A/E Technology Approval of Fuji Clean Models CEN5, CEN7, and CEN10 dated November 27, 2019 remains in effect.

If you have any questions please contact Brian Lafaille, PE at (401) 222-3961, ext. 7731 or via email at [brian.lafaille@dem.ri.gov](mailto:brian.lafaille@dem.ri.gov).

Sincerely,

  
Mohamed J. Freij, PE, PLS  
Supervising Environmental Engineer  
Onsite Wastewater Treatment Systems Program

MJF:bd1

pc: Fuji Clean A/E Technology File

Ecc: [scott@fujicleanusa.com](mailto:scott@fujicleanusa.com)  
Brian Lafaille, DEM/OWTS  
Jacqueline Tedesco, DEM/OWTS